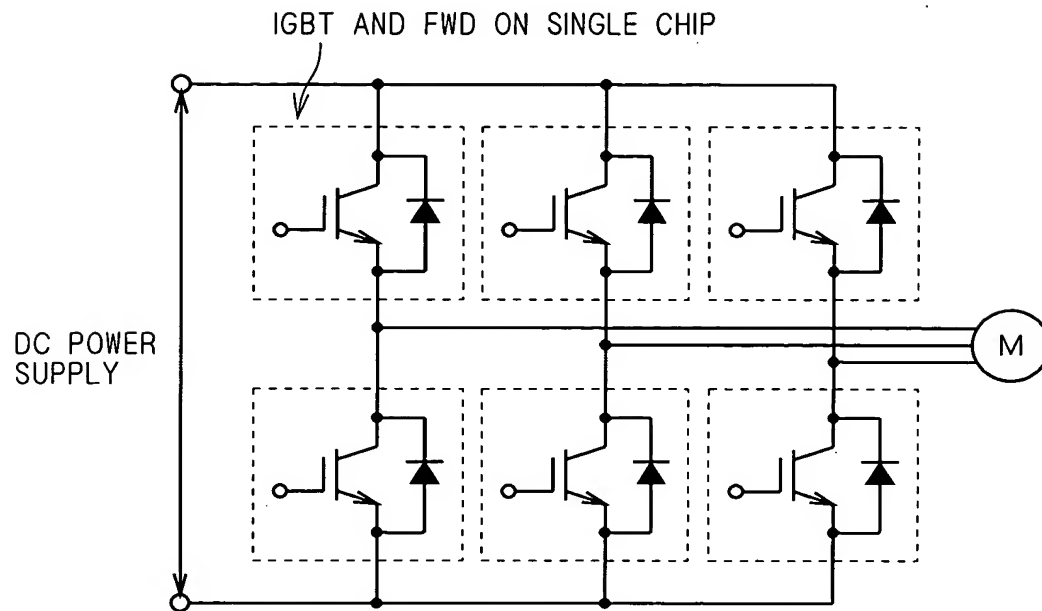
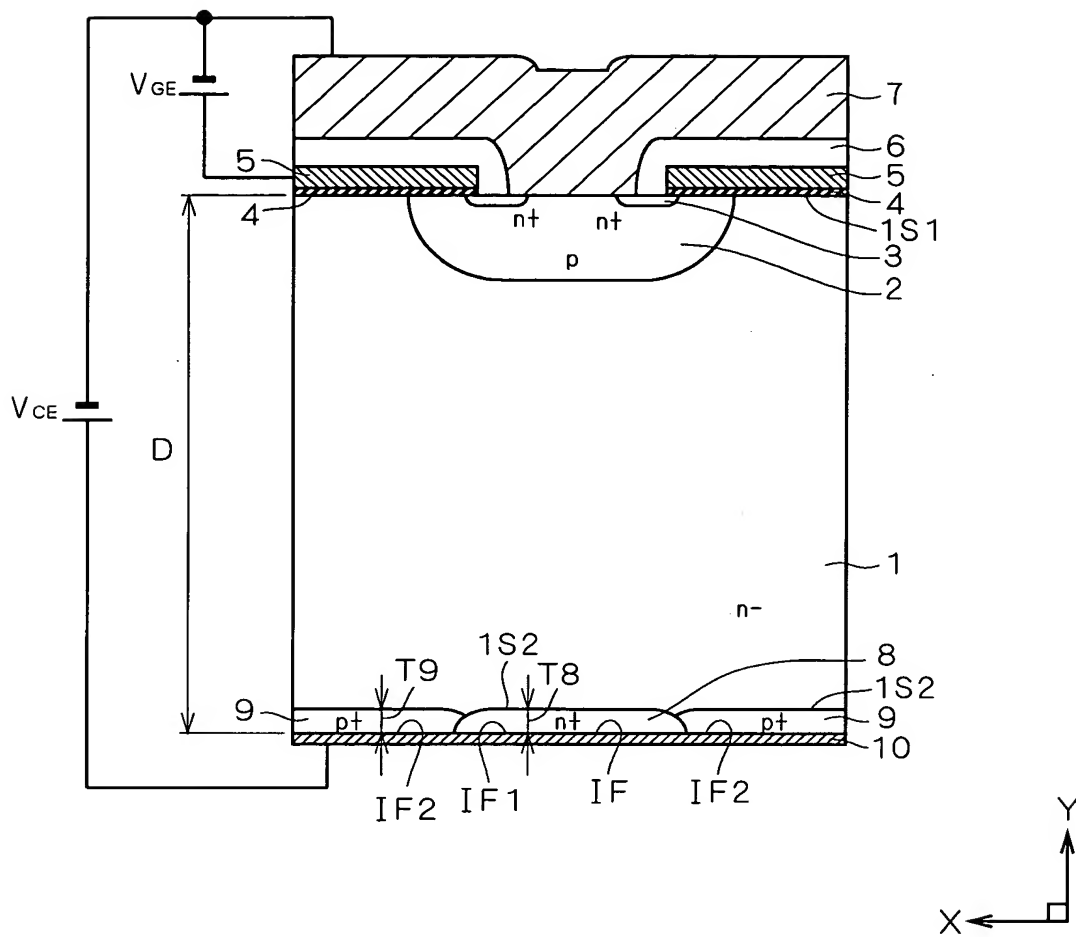


F I G . 1





F I G . 3

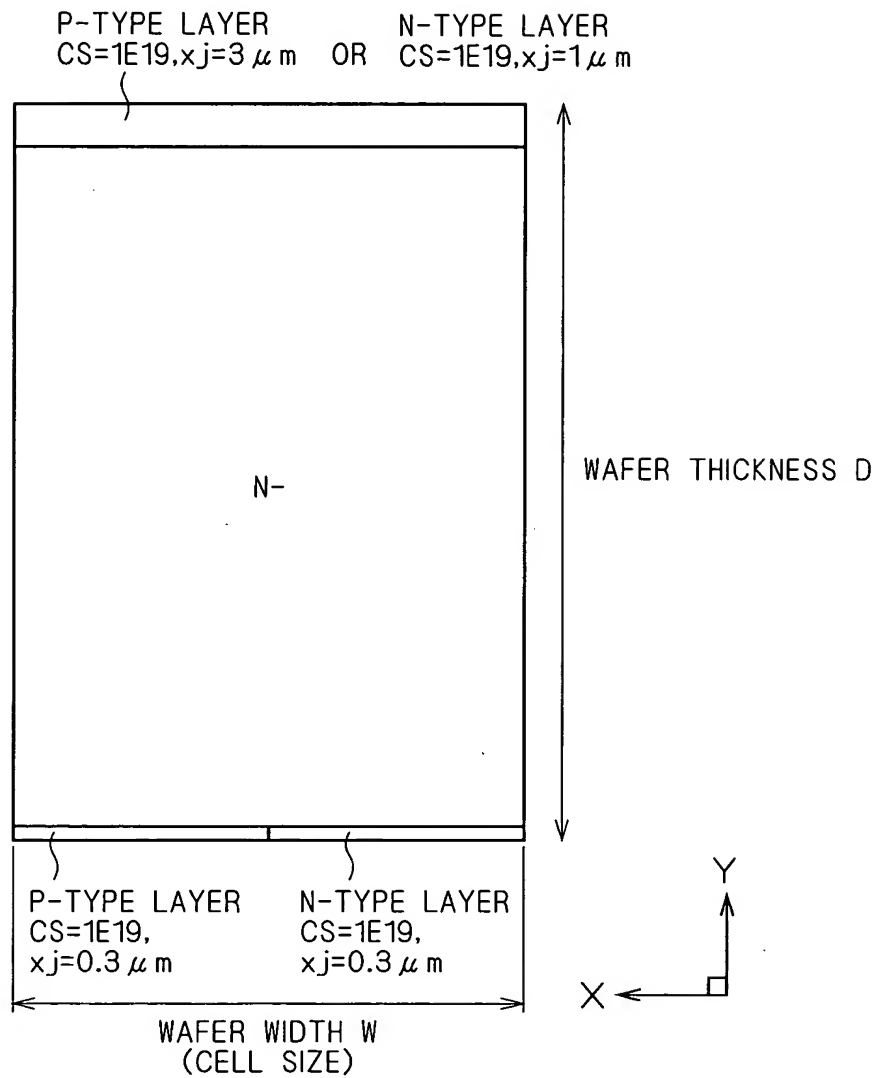


FIG. 4 A

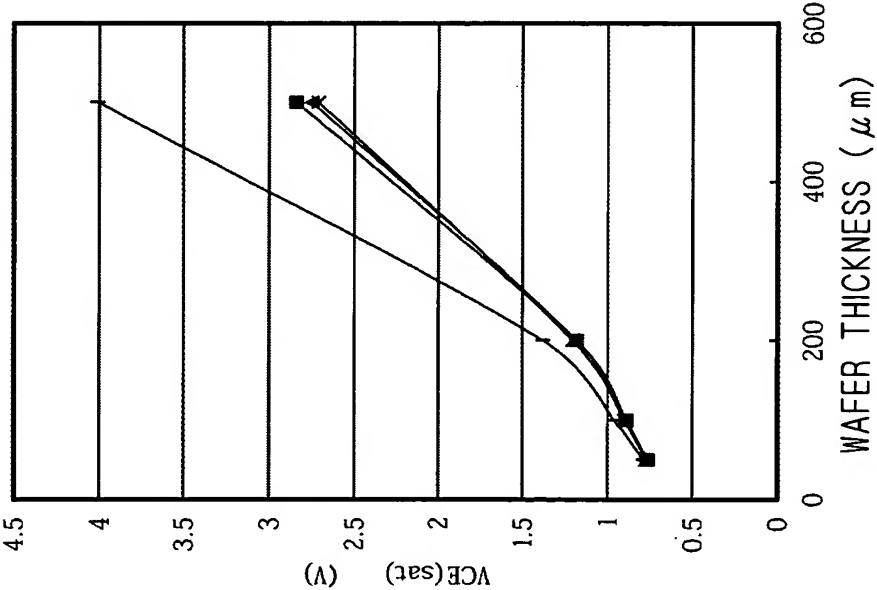
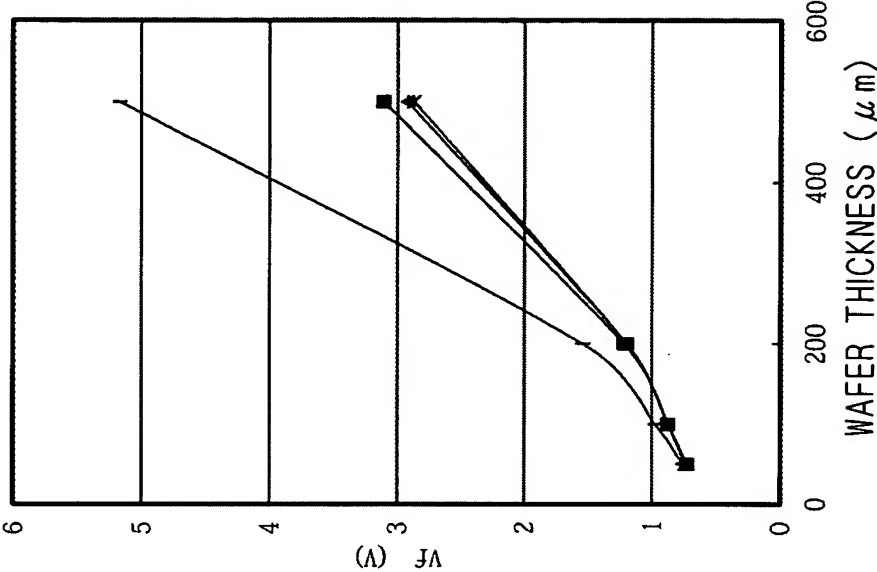
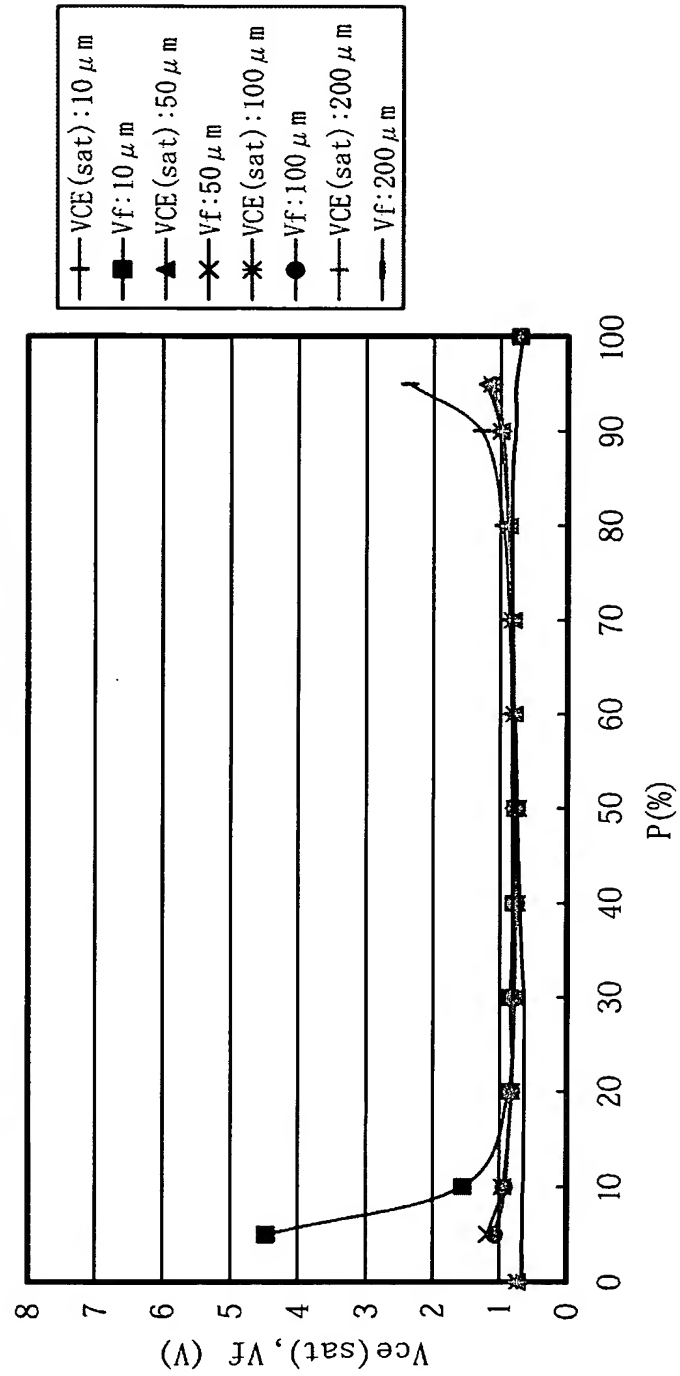


FIG. 4 B

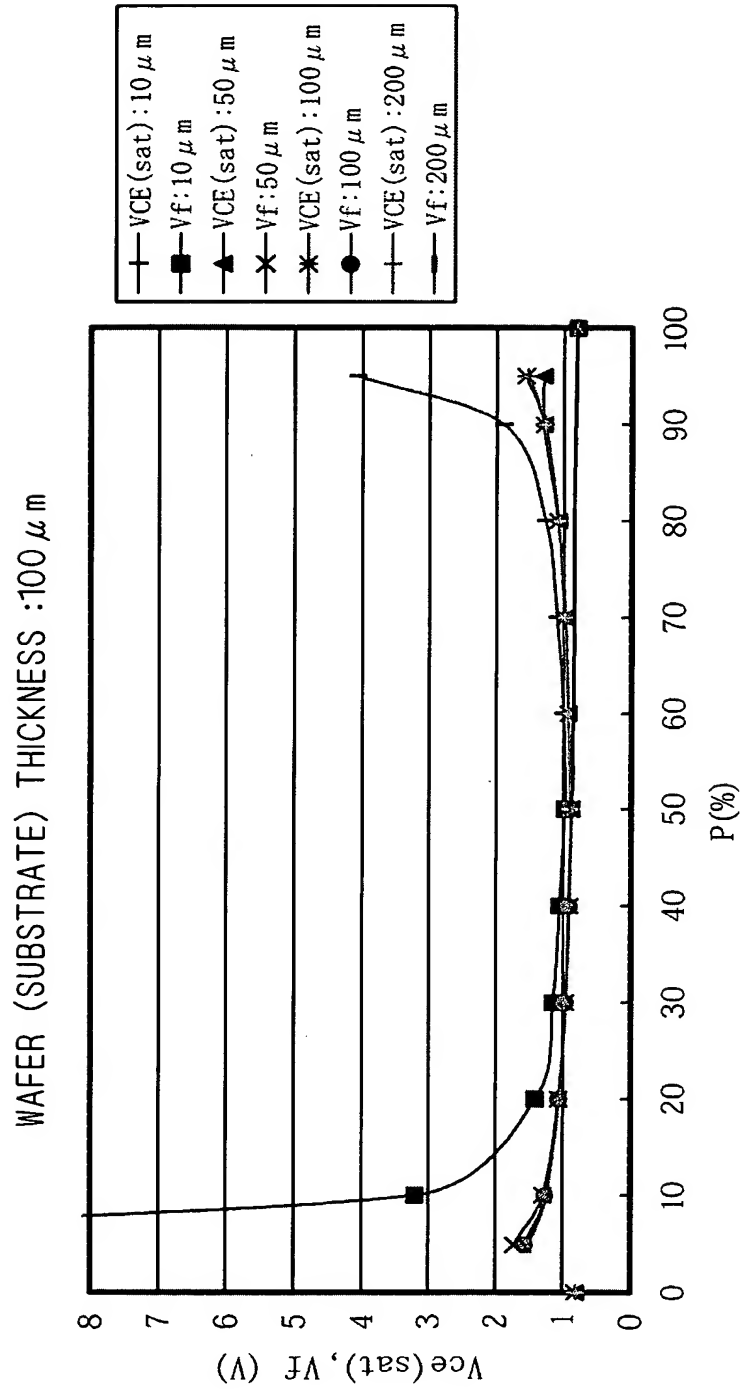


F I G . 5

WAFER (SUBSTRATE) THICKNESS :50  $\mu$  m

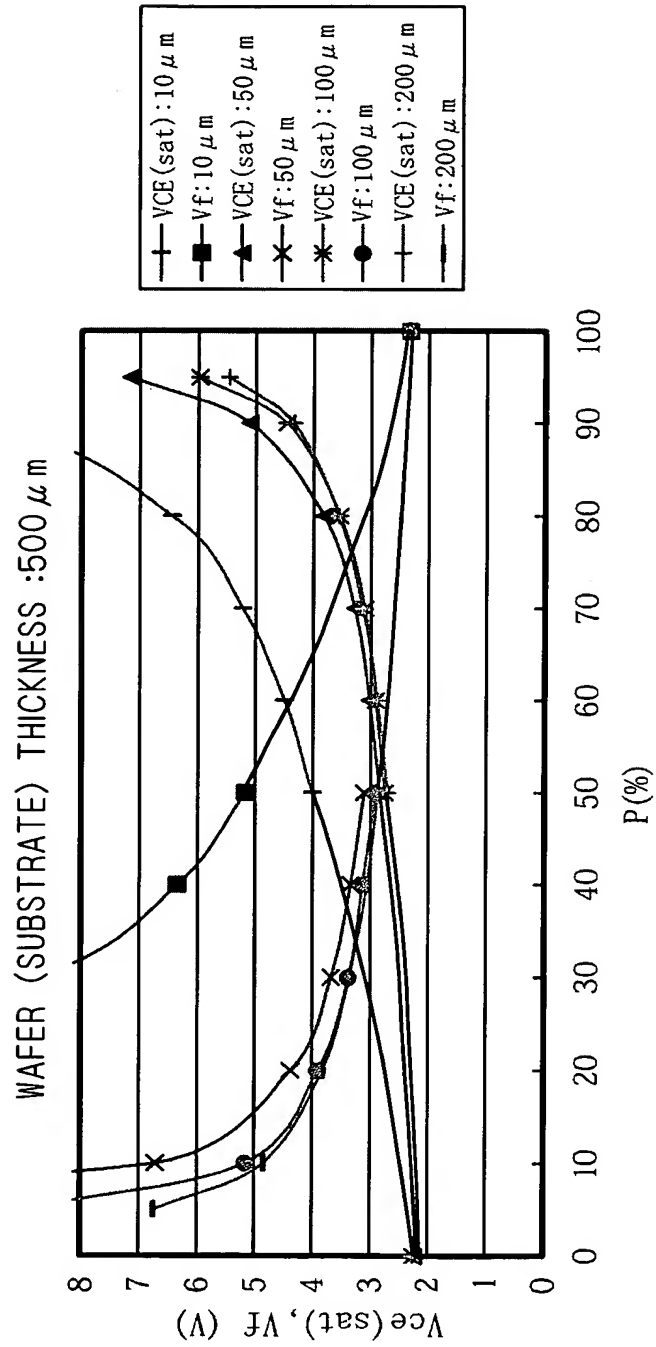


F I G . 6

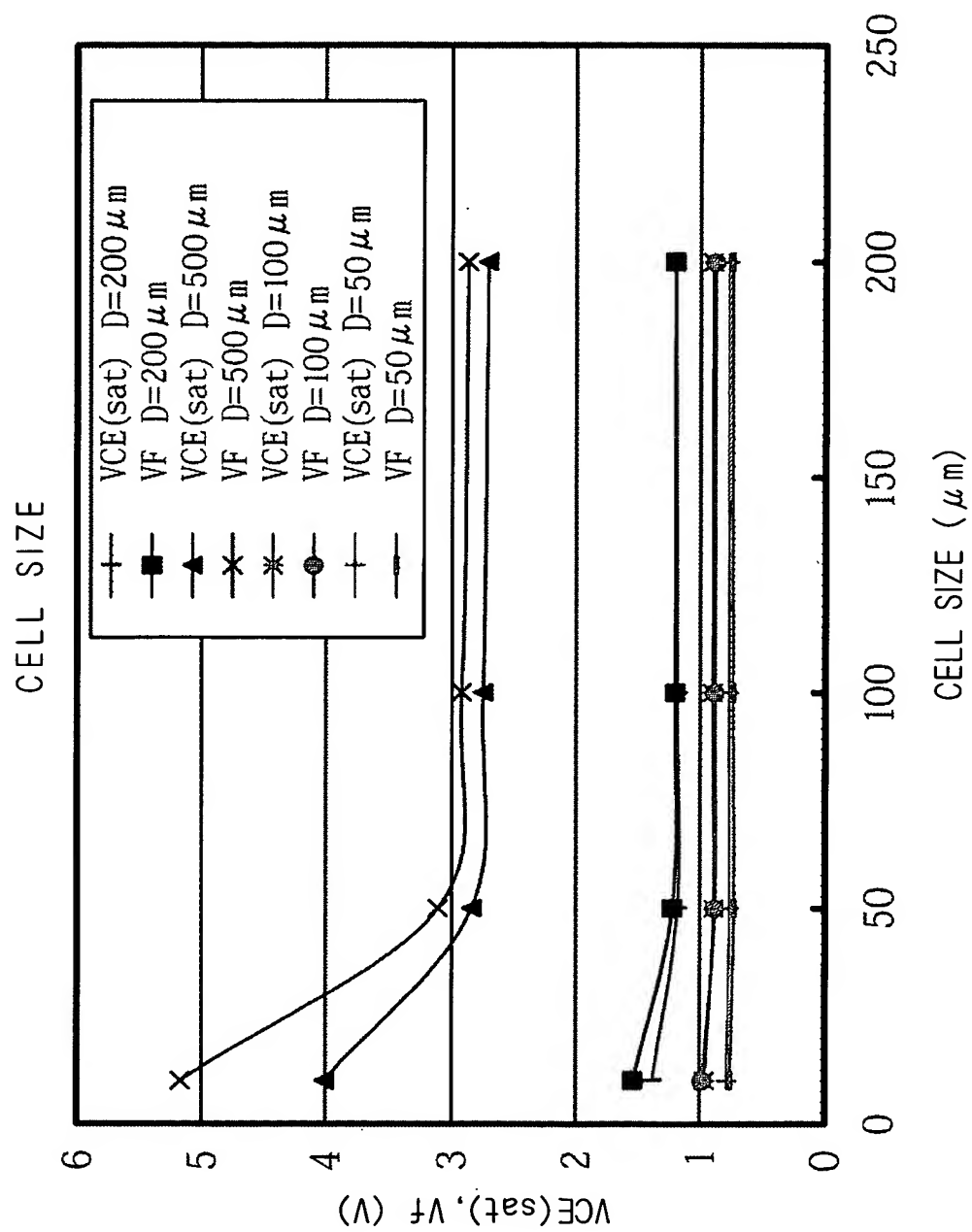


7. GG.

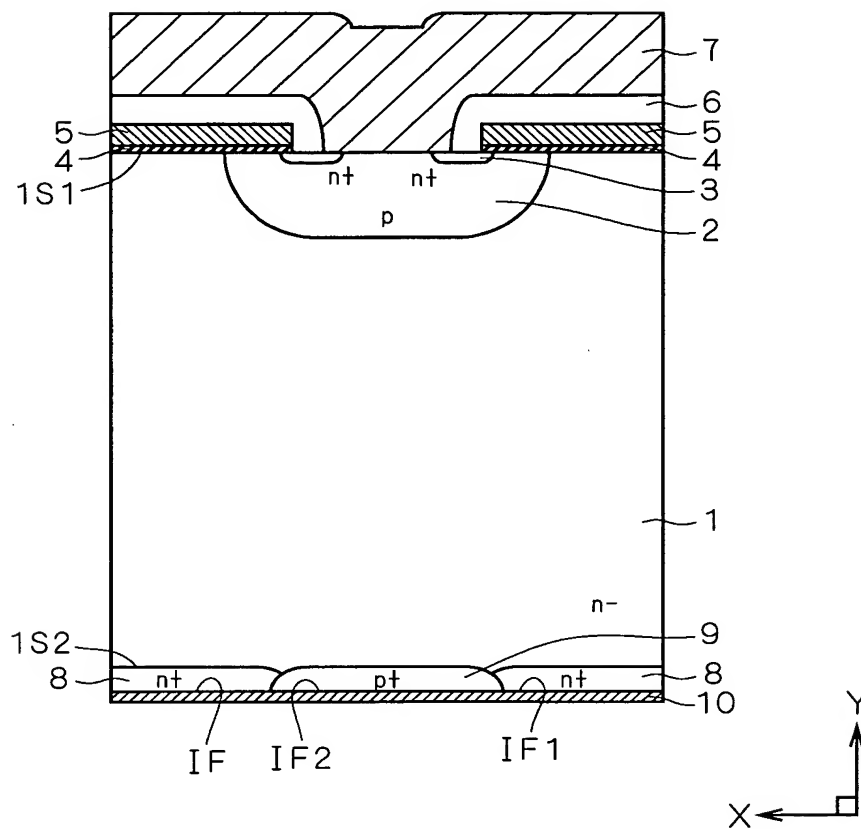




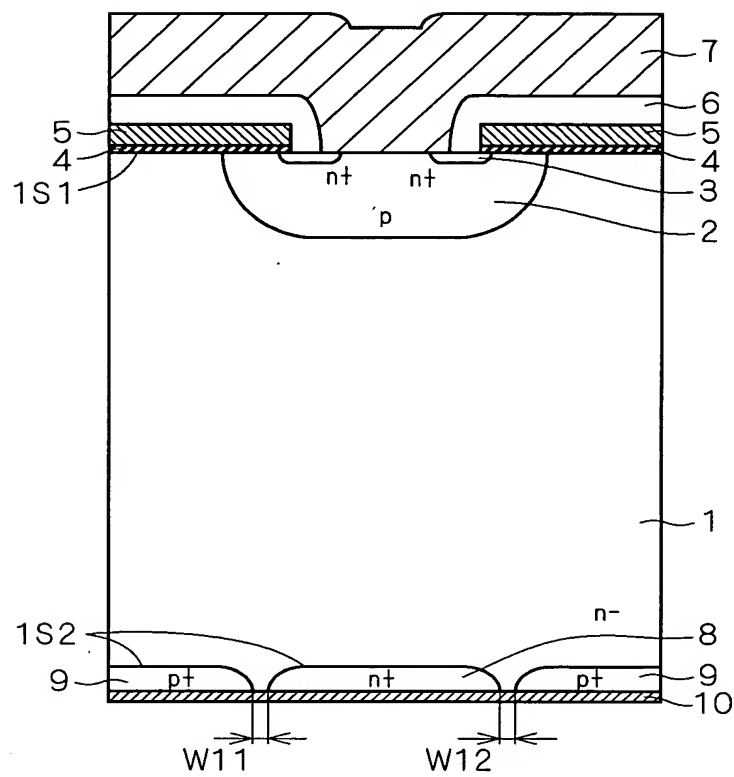




F I G . 1 0

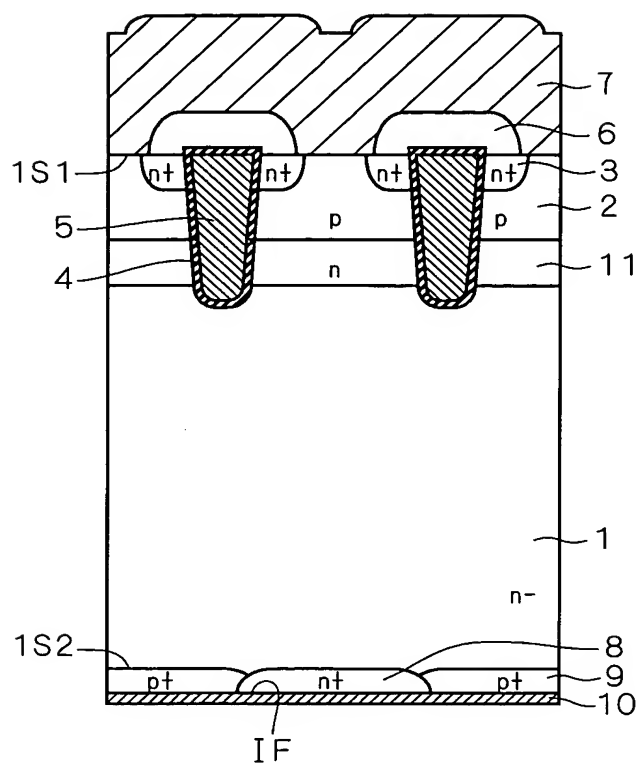


F I G . 1 1

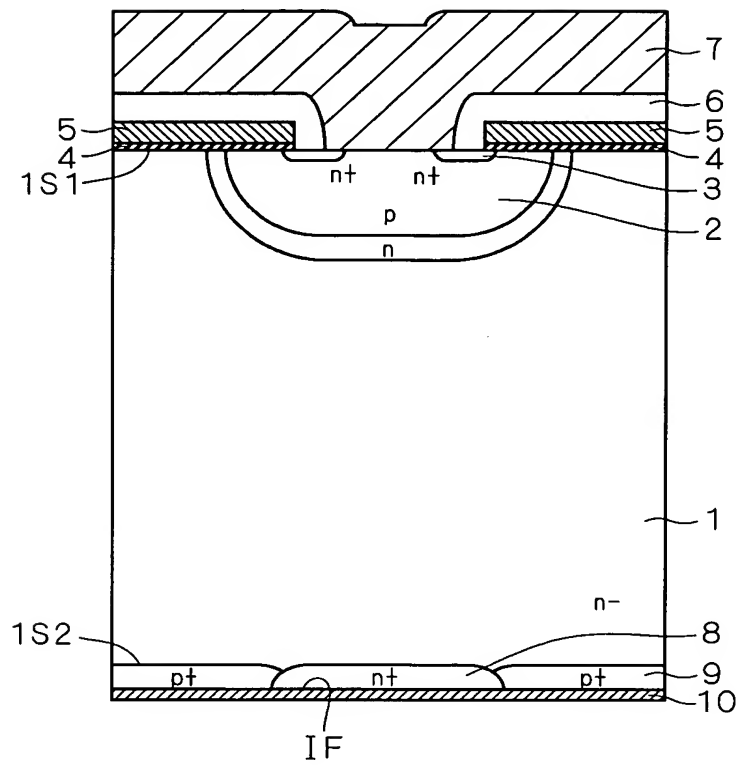




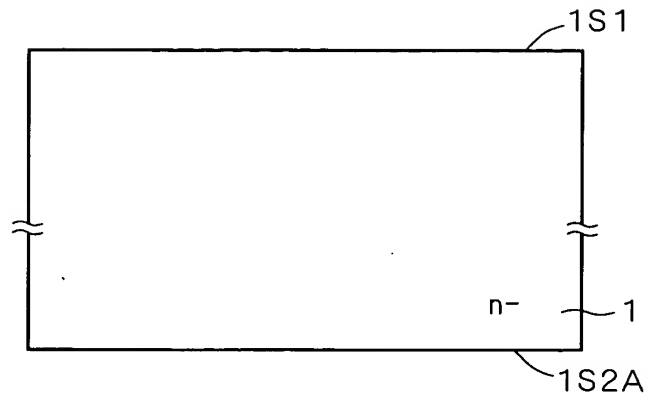
F I G . 1 3



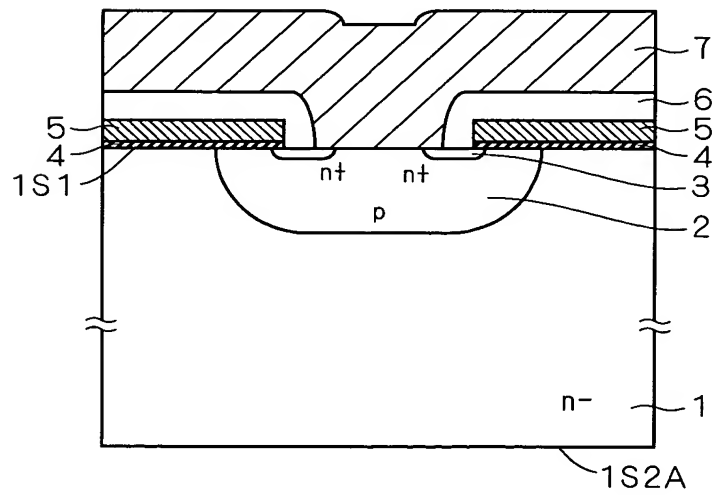
F I G . 1 4



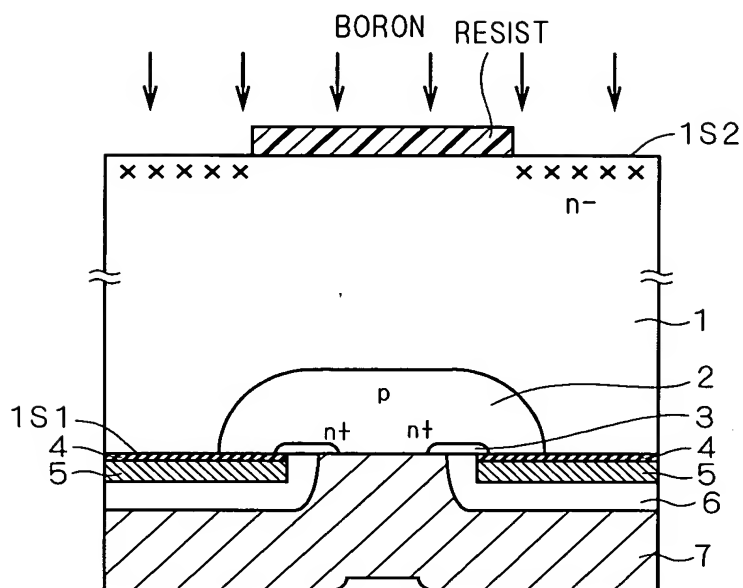
F I G . 1 5



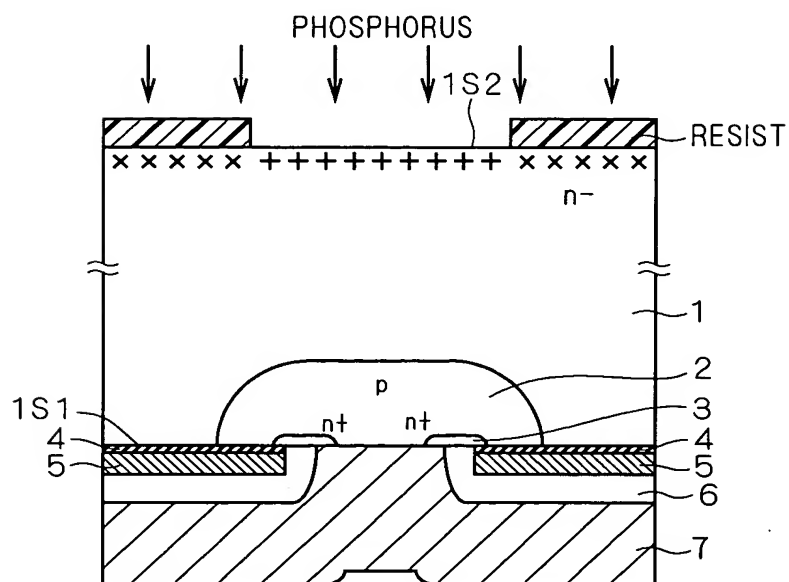
F I G . 1 6



F I G . 1 7

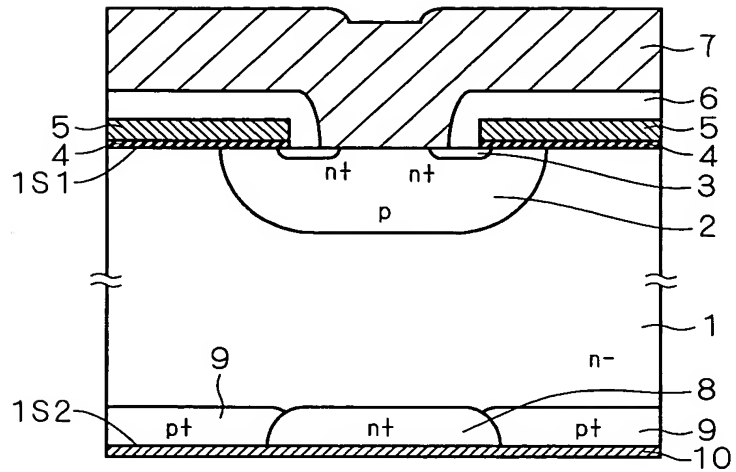


F I G . 1 8

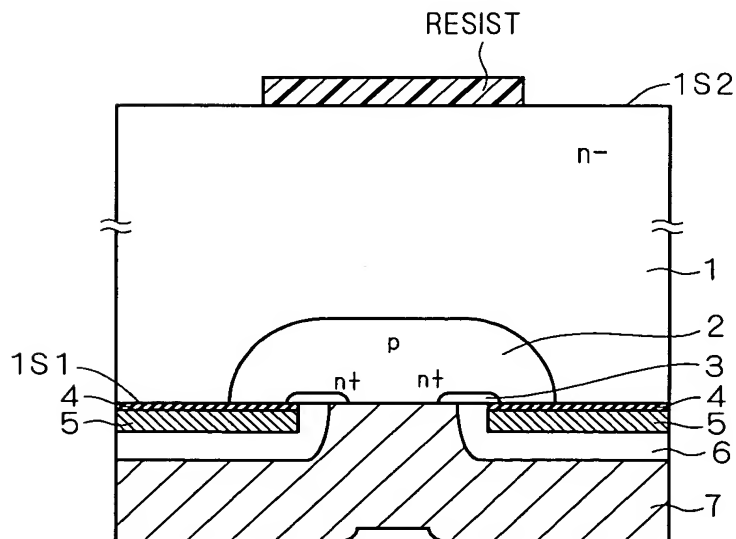




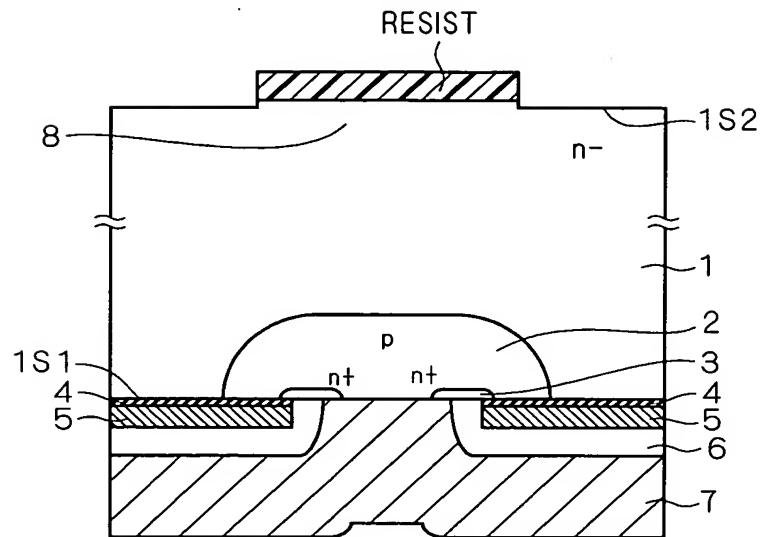
F I G . 1 9



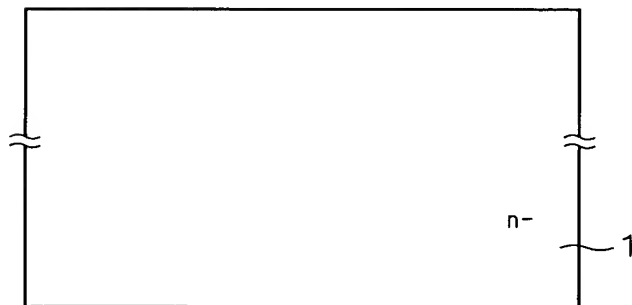
F I G . 2 0



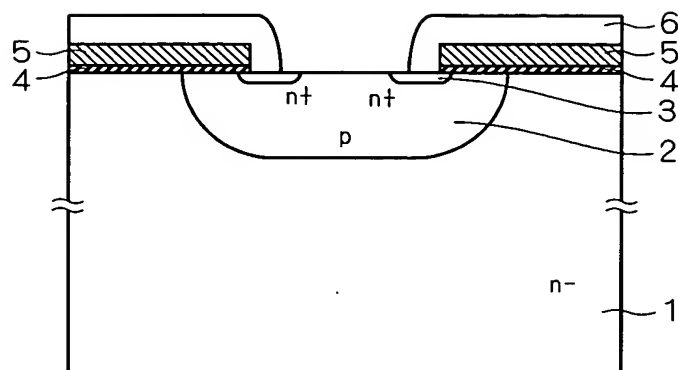
F I G . 2 1



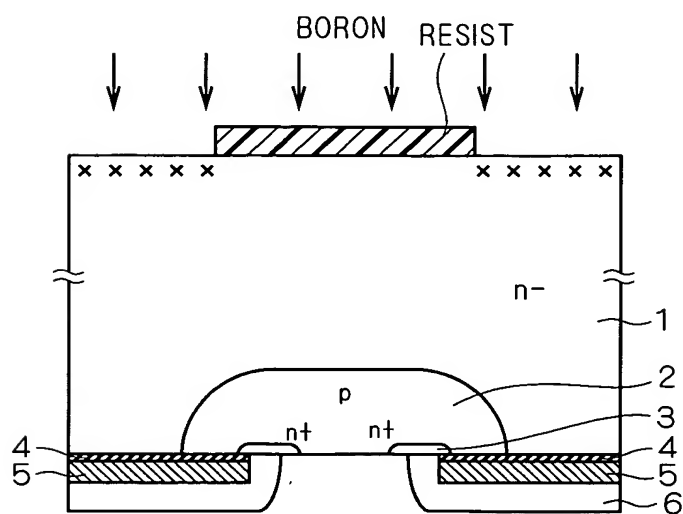
F I G . 2 2



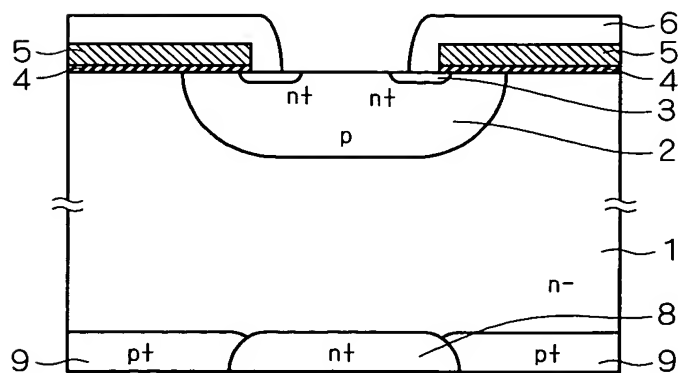
F I G . 2 3



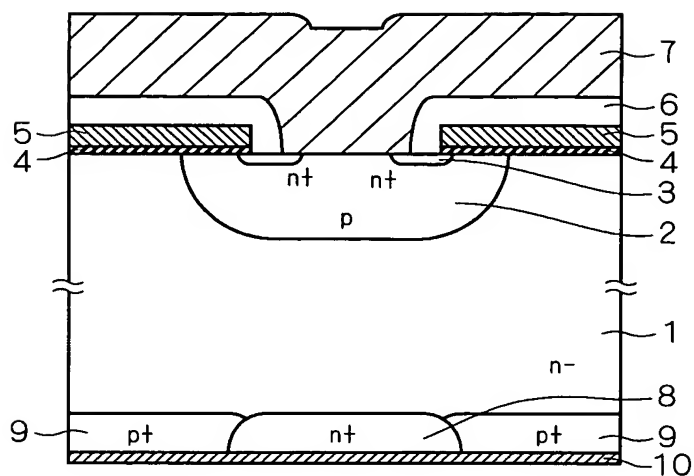
F I G . 2 4



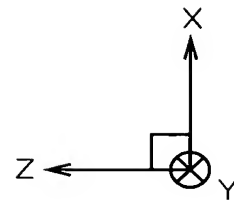
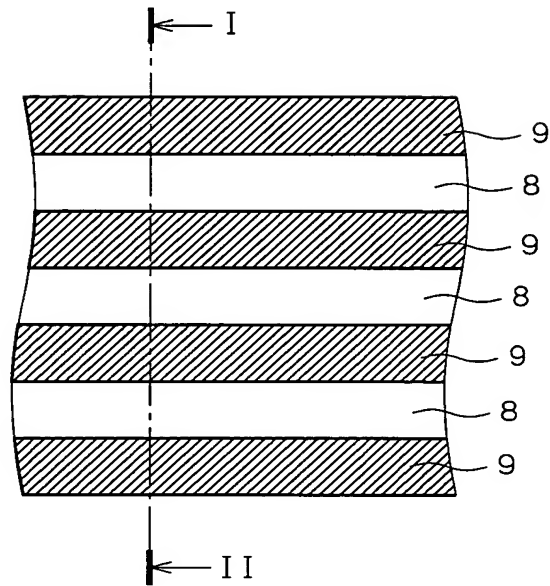
F | G . 2 6



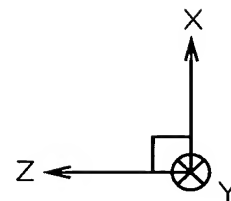
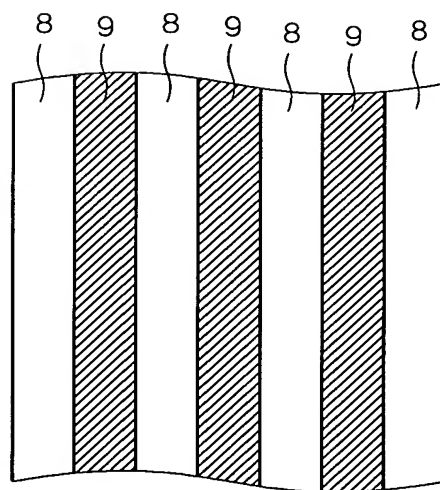
F I G . 2 7



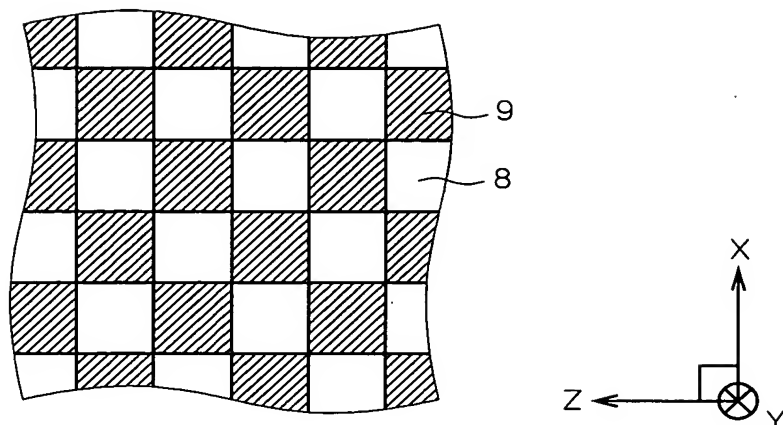
F I G . 2 8



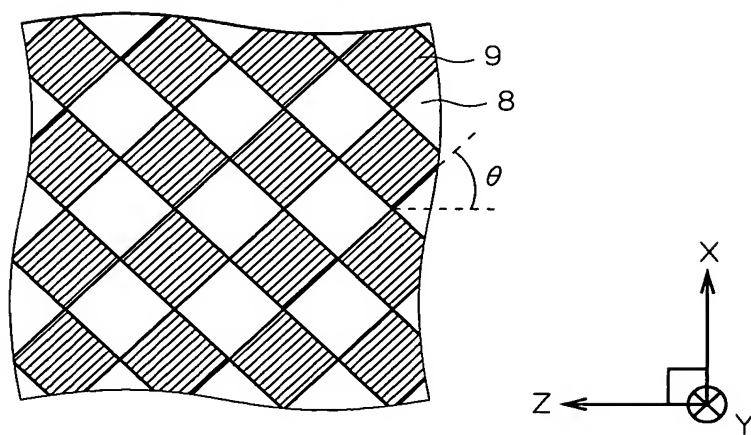
F I G . 2 9



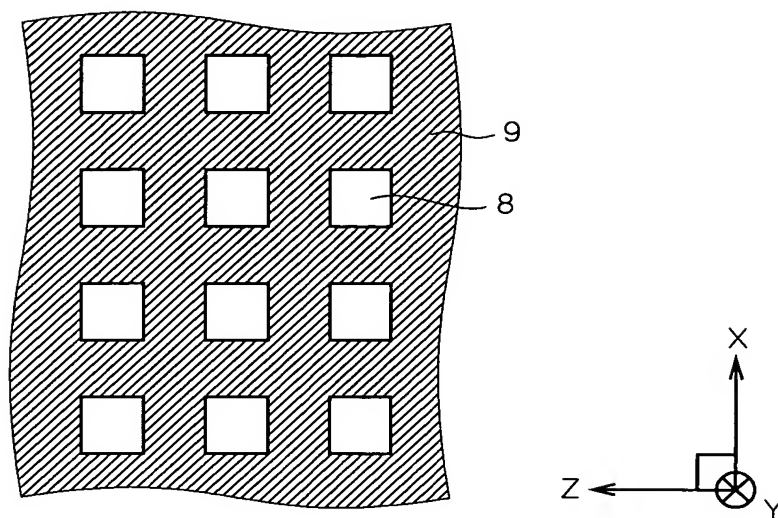
F I G . 3 0



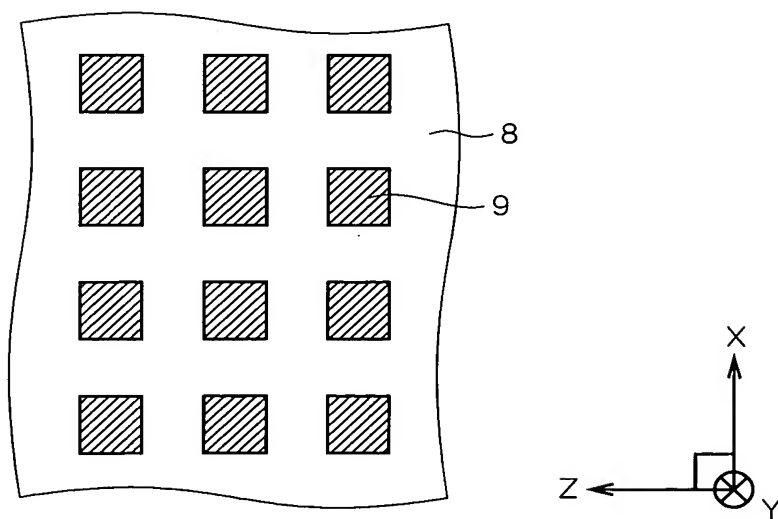
F I G . 3 1



F I G . 3 2

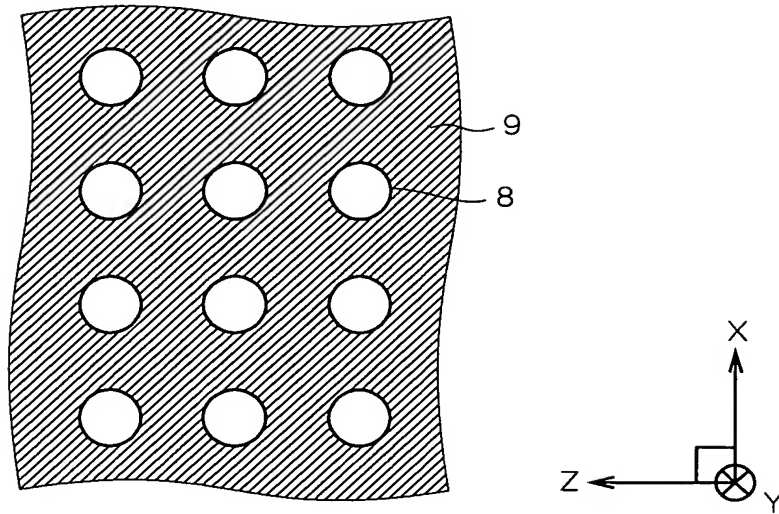


F I G . 3 3

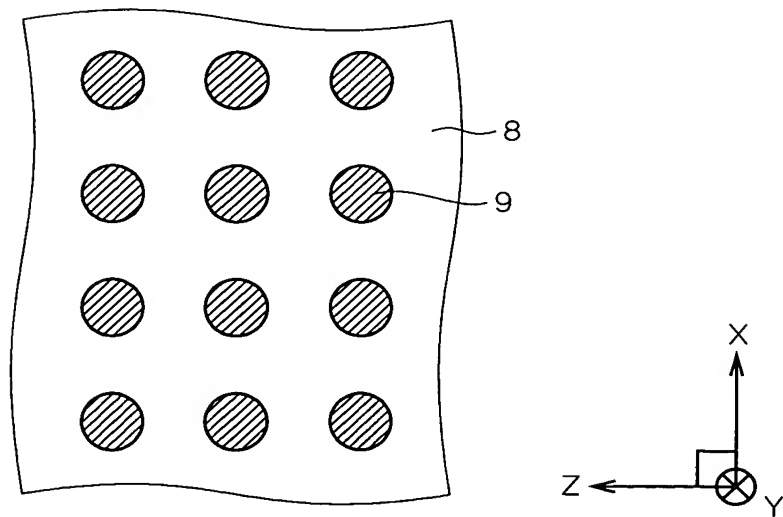




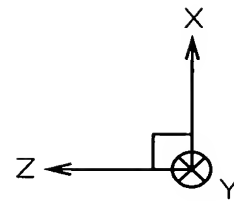
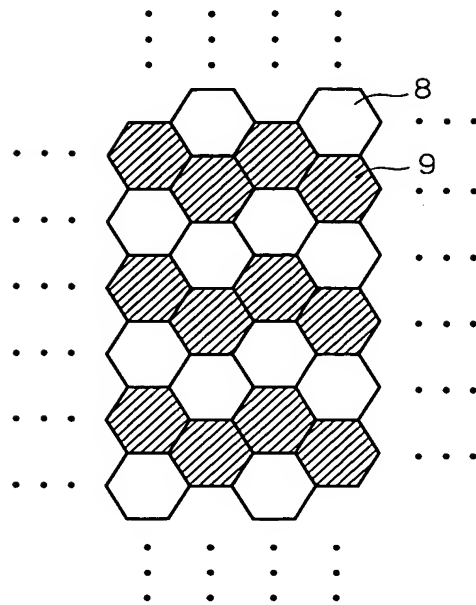
F I G . 3 4



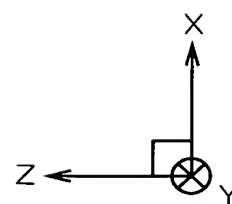
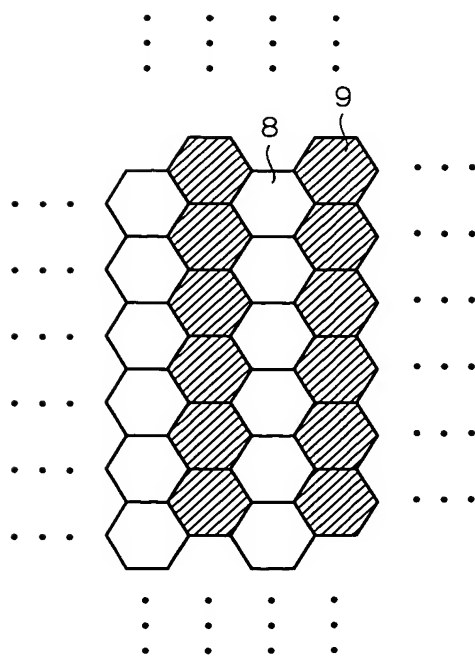
F I G . 3 5



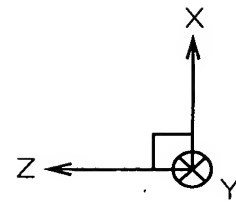
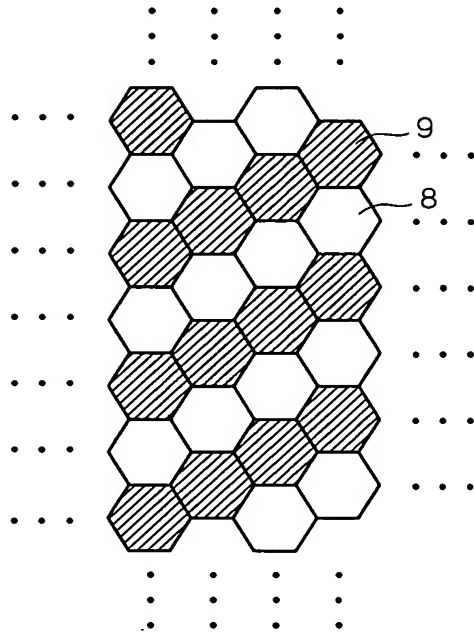
F I G . 3 6



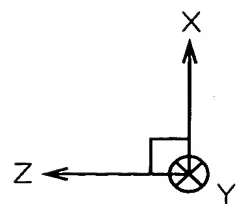
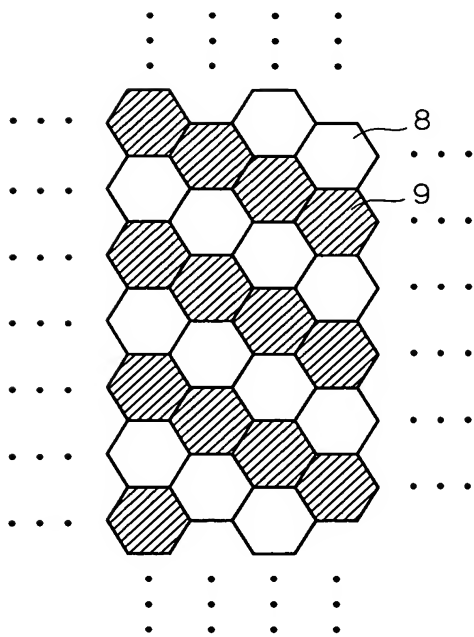
F I G . 3 7



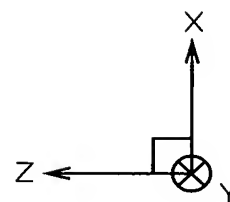
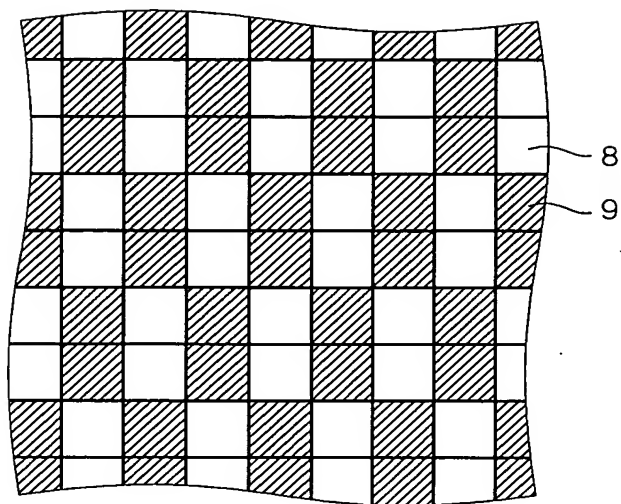
F I G . 3 8



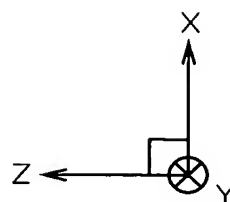
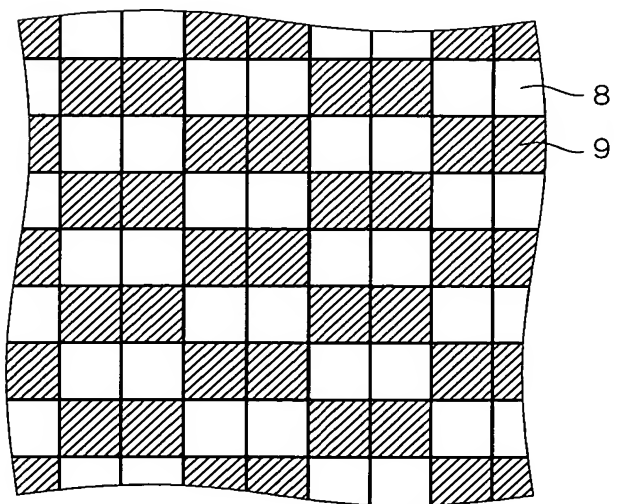
F I G . 3 9



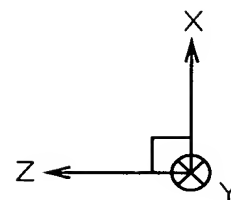
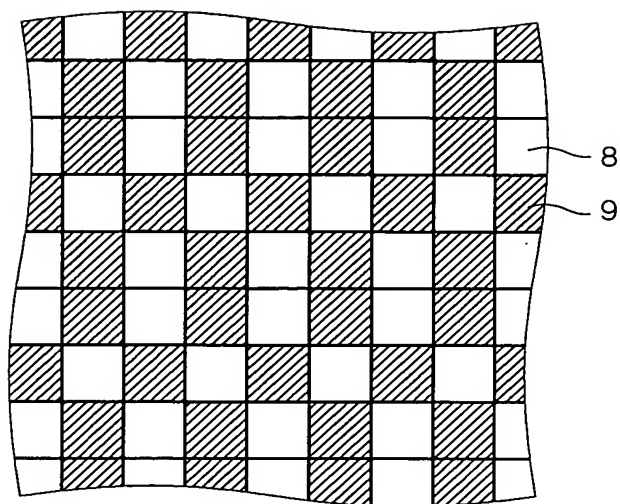
F I G . 4 0



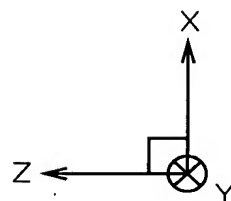
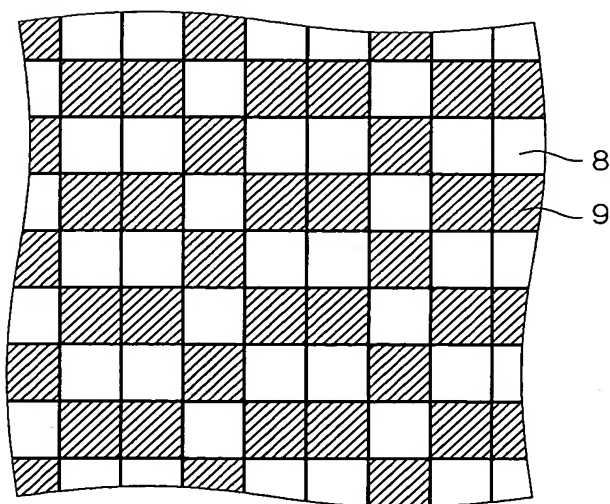
F I G . 4 1



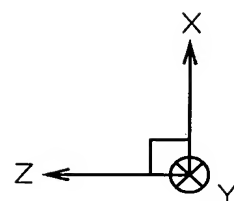
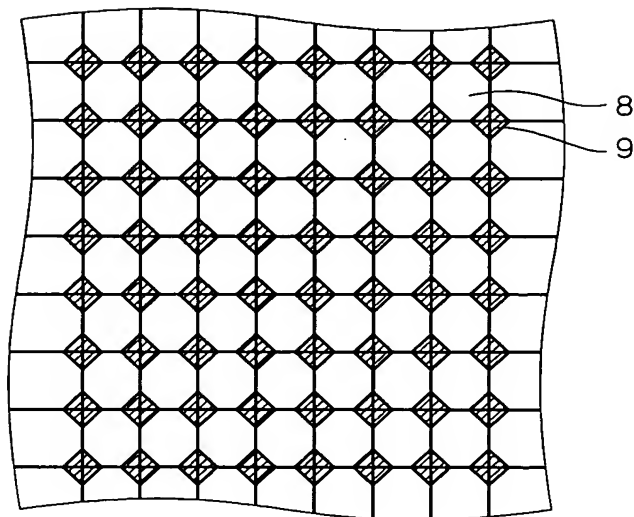
F I G . 4 2



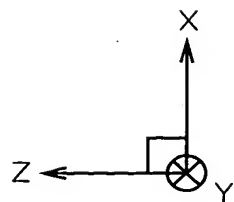
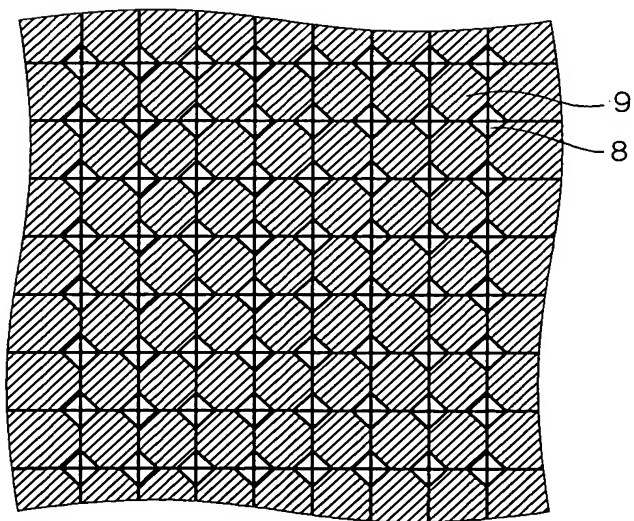
F I G . 4 3



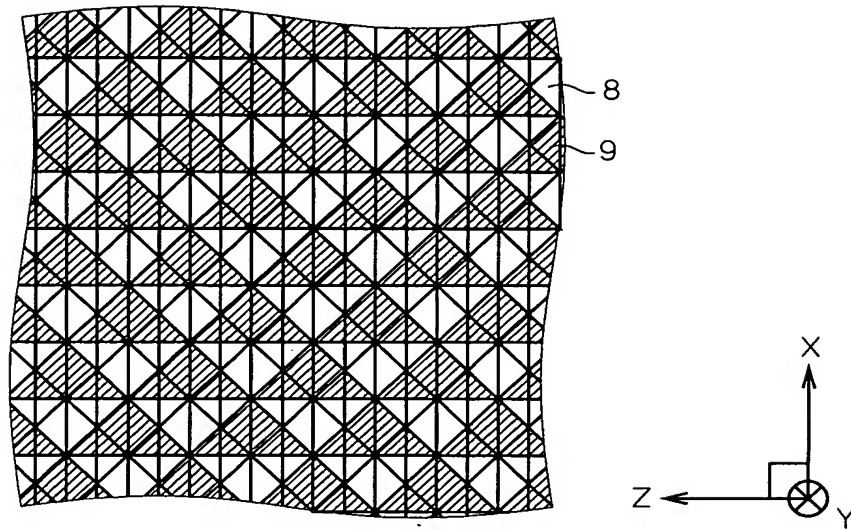
F I G . 4 4



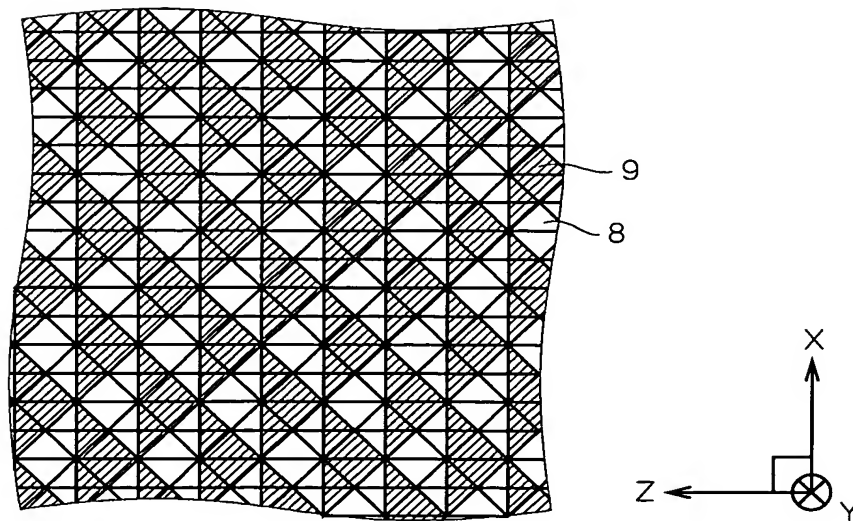
F I G . 4 5



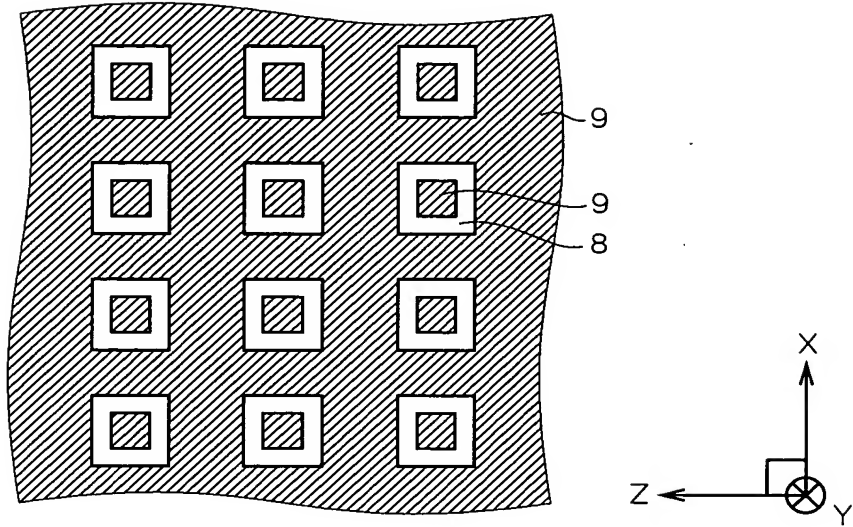
F I G . 4 6



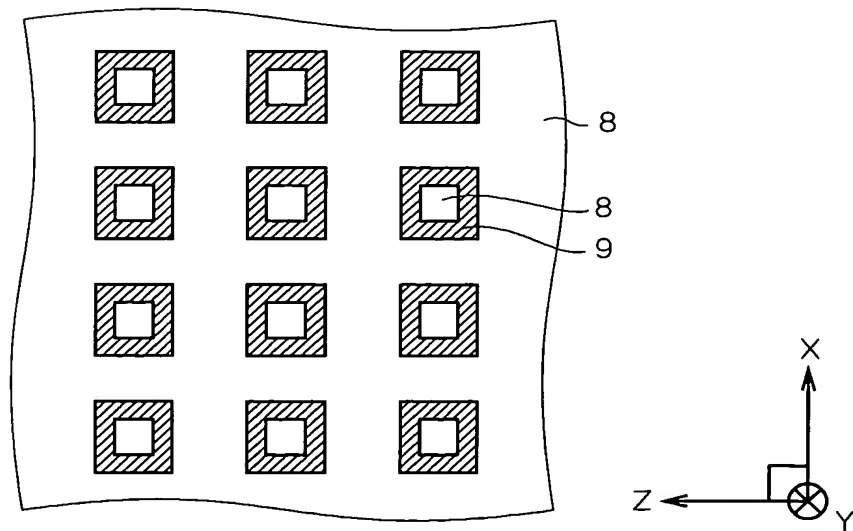
F I G . 4 7



F I G . 4 8

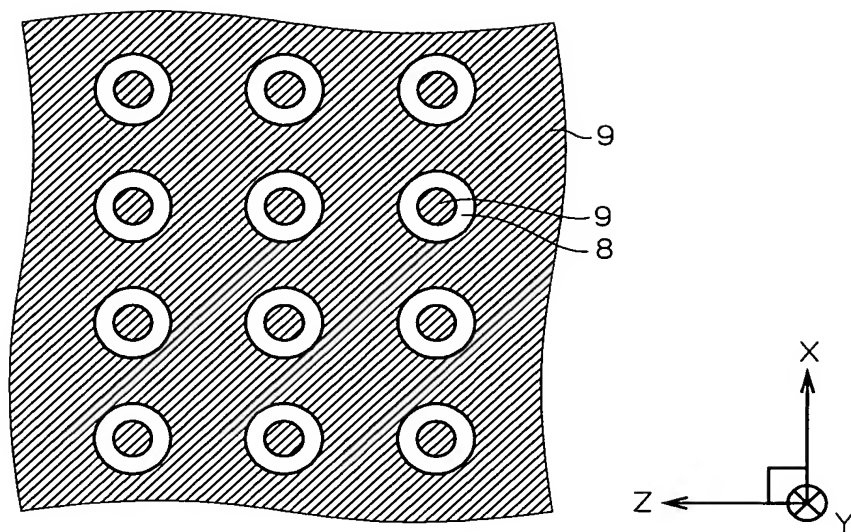


F I G . 4 9

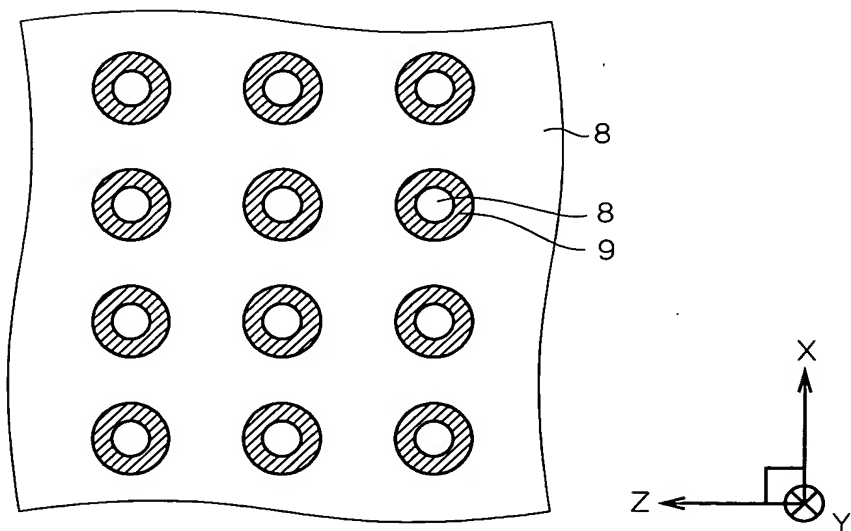




F I G . 5 0



F I G . 5 1



F I G . 5 2

